

**RESPONSE UNDER 37 CFR 1.116**  
**EXPEDITED PROCEDURE - EXAMINING GROUP 1720**  
**PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Syuji Tsukamoto et al.  
Application No. : 10/691,851  
Filed : October 23, 2003  
For : METHOD FOR CUTTING A PHOTORESIST-COATED  
GLASS BOARD, CUTTING MACHINE FOR CUTTING A  
PHOTORESIST-COATED GLASS BOARD AND  
METHOD FOR MANUFACTURING AN OPTICAL  
RECORDING MEDIUM

Examiner : Maria Alexandra Elve  
Art Unit : 1725  
Docket No. : 890050.442  
Date : April 24, 2007

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 CFR 1.116**

Commissioner for Patents:

In response to the Office Action dated January 24, 2007, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.